INTERNATIONAL SEARCH REPORT

International Application No.

_i/US2004/041884 A. CLASSIFICATION OF SUBJECT NATTER IPC 7 G01N21/956 G01B11/24 H01L21/66 G03F7/20 G06T7/00 GO1N23/22 According to International Patent Classification (IPC) or to both national classification and IPC B. FIELDS SEARCHED Minimum documentation searched (dassification system followed by classification symbols) GOIN GOIB HOIL GOSF IPC 7 GO6T Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched Electronic data base consulted during the international search (name of data base and, where practical, search terms used) EPO-Internal, INSPEC, COMPENDEX C. DOCUMENTS CONSIDERED TO BE RELEVANT Cilation of document, with indication, where appropriate, of the relevant passages Category ° Relevant to claim No. X US 6 480 807 B1 (MIYANO YUMIKO) 1-15,12 November 2002 (2002-11-12) 17-31, 33-38 column 2, line 61 - column 3, line 3 column 3, lines 20-28 column 6, lines 7-23 column 8, lines 5-45 Further documents are listed in the continuation of box C. Palent family members are listed in annex. Special categories of cited documents: "T" later document published after the International fling date or priority date and not in conflict with the application but "A" document defining the general state of the art which is not cited to understand the principle or theory underlying the considered to be of particular relevance Invention "E" earlier document but published on or after the international "X" document of particular relevance; the claimed invention filing date cannot be considered novel or cannot be considered to "L" document which may throw doubts on priority claim(s) or involve an inventive step when the document is taken alone which is cited to establish the publication date of another "Y" document of particular relevance; the claimed invention citation or other special reason (as specified) cannot be considered to involve an inventive step when the document referring to an oral disclosure, use, exhibition or document is combined with one or more other such docuother means ments, such combination being obvious to a person skilled in the art. document published prior to the international filing date but later than the priority date claimed "&" document member of the same patent family Date of the actual completion of the international search Date of mailing of the international search report

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